



Docket No.: 0171-1022P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Takeshi KINSHO et al.

Application No.: 10/671,732

Confirmation No.: 6775

Filed: September 29, 2003

Art Unit: 1752

For: POLYMERIZABLE SILICON-CONTAINING  
COMPOUND, MANUFACTURING METHOD,  
POLYMER, RESIST COMPOSITION AND  
PATTERNING PROCESS

Examiner: S. J. Lee

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated July 18, 2006, finally rejecting claim 1, please  
amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2  
of this paper.

**Remarks** begin on page 11 of this paper.

Please  
Enter  
S.J.L.  
10/30/06  
S. J. Lee